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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Eiju KOMURO et al.

Group Art Unit : 2812

Appl. No. : 10/811,812

Examiner : Not Yet Assigned

Filed : March 30, 2004

Confirmation No. : 2851

For : METHOD OF MANUFACTURING A PIEZOELECTRIC THIN FILM
RESONATOR, MANUFACTURING APPARATUS FOR A
PIEZOELECTRIC THIN FILM RESONATOR, PIEZOELECTRIC
THIN FILM RESONATOR, AND ELECTRONIC COMPONENT

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

U.S. Patent and Trademark Office
220 20th Street S.
Customer Window, Mail Stop _____
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir :

In accordance with the duty of disclosure under 37 C.F.R. §1.56 and §§1.97-1.98 and supplemental to the Information Disclosure Statement that was filed on June 30, 2004, Applicants hereby submit a copy of a Notice of Reasons for Refusal from the Japanese Patent Office together with an English language translation of the same, with respect to patent family member Japanese Patent Application No. JP 2003-94569, in which the following documents were cited:

Japanese Laid-Open Patent Publication No. HEI 10-126160, which was published on May 15, 1998, together with an English language Abstract of the same and an English language translation of selected portions of the same;

Japanese Laid-Open Patent Publication No. 2002-335141, which was published on November 22, 2002, together with an English language Abstract of the same and an English language translation of selected portions of the same; and

Japanese Laid-Open Patent Publication No. 2002-344280, which was published on November 29, 2002, together with an English language Abstract of the same and an English language translation of selected portions of the same.

Applicants respectfully request that the Examiner consider the above material and cite the same. Copies of the above-noted documents are attached hereto and are listed on the attached PTO-1449 Form. The Examiner is requested to initial the appropriate spaces on the attached Form and to return a copy of the completed Form to the Applicants with the next official communication in the present application.

Applicants note that an Office Action on the merits has not issued in the present application, and thus no fee is believed necessary to ensure consideration of the submitted material. However, if an Office Action on the merits has issued and is crossing this statement in the mail, the undersigned hereby authorizes the Commissioner to charge any fee necessary for the consideration of this statement, including any payment under 37 C.F.R. §1.17 (p) to Deposit Account No. 19-0089.

Should the Examiner have any questions, the Examiner is invited to contact the undersigned at the below-listed telephone number.

Respectfully Submitted,
Eiju KOMURO et al.

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August 3, 2004
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Application No.
10/811,812

INFORMATION DISCLOSURE STATEMENT
BY APPLICANT
(Use several sheets if necessary)

Group
2812

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.